

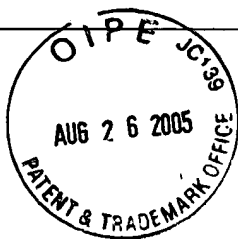
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tsuruta

Serial No.: 10/699,831

Filed: 11/4/2003

Title: SEMICONDUCTOR SUBSTRATE
AND MANUFACTURING PROCESS
THEREFOR



Atty. Dkt.: 11-202

Art Unit: 2815

Examiner: Matthew E. WARREN

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany St.
Alexandria, VA 22314

Date: 26 August 2005

AMENDMENT UNDER 37 CFR 1.111

Sir:

In response to the office action mailed 3 May 2005, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 8 of this paper.